

INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

December 13, 2025

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG756510186

LABORATORY GROWN DIAMOND

OVAL BRILLIANT

13.82 X 8.69 X 5.19 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

4.03 CARATS

E

VS 1

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

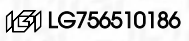
EXCELLENT

EXCELLENT

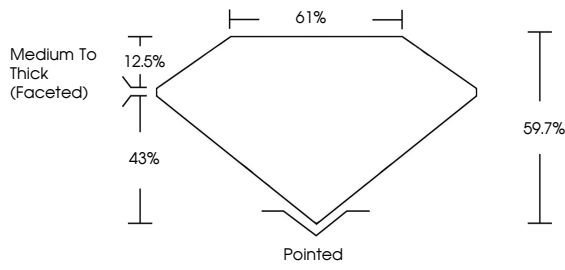
NONE

Inscription(s)

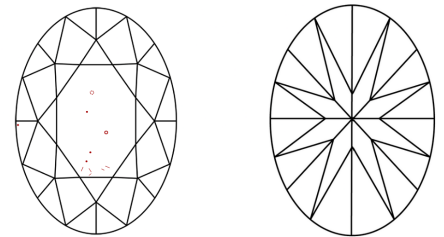
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



PROPORTIONS



CLARITY CHARACTERISTICS




KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

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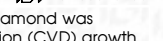
EXCELLENT

EXCELLENT

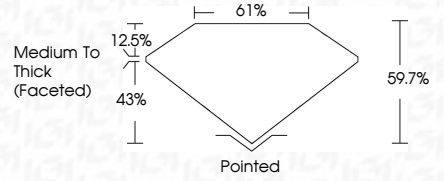
NONE

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PROPORTIONS



COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

FL

IF

VVS<sup>1-2</sup>

VS<sup>1-2</sup>

SI<sup>1-2</sup>

I<sup>1-3</sup>

Flawless

Internally Flawless



Very Very Slightly Included

Very Slightly Included

Slightly Included

Included

IGI



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December 13, 2025

IGI Report No LG756510186

OVAL BRILLIANT

13.82 X 8.69 X 5.19 MM

4.03 CARATS

E

VS 1

61%

59.7%

Medium To Thick (Faceted)

Pointed

EXCELLENT

EXCELLENT

NONE

IGI LG756510186

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

None

Excellent

Excellent

None

IGI LG756510186

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